



IFW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2813

Application No.: 10/507,175

Examiner: C. RODGERS

Filed: September 10, 2004

Docket No.: 121026

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 25, 2006 Office Action, please consider the following:

**Amendments to the Drawings** include an attached replacement sheets; and

**Remarks.**